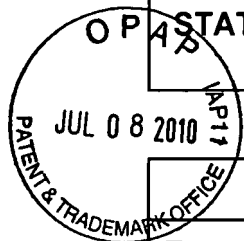


INFORMATION DISCLOSURE STATEMENT	Application No.: 10/822,891	Sheet 1 of 1
	Docket No.: SNY-T5707.02	Group: 2423
	Filed: 04/13/2004	Conf. No.: 4007
	Applicant: Candelore et al.	



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	JP 61-264371	11/22/1986	Japan		Yes**

** Partial translation submitted in IDS 4/6/2010.

OTHER DOCUMENTS / CITATIONS	
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Examiner:	Date:
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APPENDIX

These references are cited in one or more applications related to this patent application in US Office Actions. In some instances, art cited in this and other IDS may not constitute prior art to the present application. Below is a list of references received with reference to the corresponding application number.

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